Effect of high-\(\kappa\) gate dielectrics on charge transport in graphene-based field effect transistors

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The effect of various dielectrics on charge mobility in single-layer graphene is investigated. By calculating the remote optical phonon scattering arising from the polar substrates, and combining it with their effect on Coulombic impurity scattering, a comprehensive picture of the effect of dielectrics on charge transport in graphene emerges. It is found that though high-\(\kappa\) dielectrics can strongly reduce Coulombic scattering by dielectric screening, scattering from surface phonon modes arising from them wash out this advantage. Calculation shows that within the available choice of dielectrics, there is not much room for improving carrier mobility in actual devices at room temperatures.

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I. INTRODUCTION

Graphene, a two-dimensional (2D) gapless semiconductor with a honeycomb crystal structure of carbon atoms, has gained significant attention recently owing to its conical band structure,\(^1\) unconventional noninteger quantum-Hall effect,\(^2,3\) possible applications emerging from high room-temperature (RT) electron mobility (\(\sim 10^4\) cm\(^2\)/Vs),\(^4\) and tunable band gaps in nanostructures carved from it.\(^5,6\) Appreciable modulation of current by electrostatic gating indicate graphene as an excellent material for conventional and possibly novel electronic devices.\(^7\) High mobilities can facilitate coherent ballistic transport over large length scales. This can enable novel devices that exploit the wavelike features of electrons, resulting in “electron optics” in the nanoscale material.\(^8\)

For graphene located in close proximity to dielectric substrates, the highest RT carrier mobilities experimentally reported are in the \(\sim 10^4\) cm\(^2\)/Vs range\(^9\) for 2D carrier concentrations in the \(\sim 10^{12}\) cm\(^{-2}\) regime. However, suspending graphene by removing the underlying substrate and driving off impurities sticking to it resulted in much higher mobilities near RT, albeit at low carrier concentrations\(^10−12\) When compared to 2D electron gases (2DEGs) in narrow-band-gap III-V semiconductor heterostructures such as InAs and InSb,\(^13\) mobilities and low-field conductivities (charge \(\times\) mobility) in 2D graphene on dielectric substrates reported to date are lower.

Recently, it was predicted that for thin semiconducting nanostructures, impurity scattering can be reduced by surrounding the structure with high-\(\kappa\) dielectrics,\(^14,15\) and a recent experimental observation was made for graphene.\(^16\) The reduction in impurity scattering is affected by the reduction in Coulomb scattering by the high-\(\kappa\) dielectric. However, several recent works have pointed out that high-\(\kappa\) dielectrics in close proximity with a conducting channel in a semiconductor lead to enhanced surface-optical (SO) phonon scattering due to remote optical-phonon coupling between electrons in the channel and polar vibrations in the dielectric. This feature presents itself not only in graphene\(^9,17,18\) but in carbon nanotubes,\(^19\) as well as in the workhorse of the electronics industry-silicon metal-oxide field-effect transistors (MOSFETs).\(^20\)

At low electric fields, intravalley and intervalley optical-phonon scattering is negligible due to the insufficient kinetic energy of carriers. If a nominal charged impurity concentration of \(n_{\text{imp}} \sim 10^{11}/\text{cm}^2\) is present at a graphene/high-\(\kappa\) dielectric interface, for carrier concentrations \(\lesssim 10^{13}/\text{cm}^2\), acoustic-phonon scattering at RT is also relatively insignificant owing to the low density of states of graphene at the Fermi energy (see Refs. 21–24). In this technologically relevant regime, the competing effects of impurity and SO-phonon scattering are responsible for the low-field transport properties of graphene. High-\(\kappa\) gate oxides result in good electrostatic gate control of the Fermi level in the graphene layer and at the same time reduce Coulombic scattering from charged impurities. However, at the same time, they give rise to SO phonon scattering. It is imperative at this stage that this twofold role of dielectrics be studied in detail to clarify the competing roles, and consequently outline routes for retaining the high mobility and mean-free path of carriers in graphene. That is the goal of this work.

II. SURFACE PHONON AT GRAPHENE/INSULATOR INTERFACE

A. Dielectric continuum model of surface phonons

Surface modes in the phonon spectrum of a solid arise due to its finite size. In the case of a polar material, the phonon field due to longitudinal surface modes propagates along the surface and induces a nonvanishing decaying electric field outside it.\(^25\) The dispersion of these SO phonons and the induced electric field in the inversion layer of a semiconductor-oxide interface was first calculated by Wang and Mahan.\(^26\) Later, Fischetti et al.\(^27\) solved the dynamical dielectric response of a coupled channel/insulator/gate system and showed that the channel and gate plasmons can alter the dispersion relation of SO-phonon modes at semiconductor-oxide interface for a Si-MOSFET structure. In this work, we consider the gate as an ideal metal, implying that all electric field lines originating from time-dependent Coulombic fluctuations at the gate/oxide interface should terminate on the gate metal\(^27\) producing an insignificant effect on the channel (in our case graphene) dielectric response. Consider the structure as shown in Fig. 1. A dielectric of

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thickness $t_{ox}$ is deposited on a metal gate, and a single-layer graphene is placed at an equilibrium distance $d$ from the oxide, and air ($\kappa = 1$) covers the rest of the space. Denoting $q$ and $r$ as the two-dimensional wave vector and spatial vector in the graphene plane, we write the time-dependent SO-phonon field at a point $(r, z)$ as

$$\phi(r, z, t) = \sum_{q} \phi_{q,\omega}(z)e^{i(q \cdot r - \omega t)},$$

(1)

where the components of SO modes $\phi_{q,\omega}(z)$ are solutions of Maxwell’s equation given by

$$\phi_{q,\omega}(z) = \left\{ \begin{array}{ll}
0, & -\infty \leq z \leq -t_{ox}, \\
2b_{q,\omega} \sinh q(z + t_{ox}) - t_{ox} & -t_{ox} \leq z \leq 0, \\
d_{q,\omega} e^{-\omega q^2} & z \geq 0.
\end{array} \right.$$  

(2)

Here, $b_{q,\omega}$ and $d_{q,\omega}$ are normalization constants. Applying electrostatic boundary conditions at the interface, we get the secular equation

$$\epsilon_{\omega}(\omega) + \epsilon_{\omega}(q, \omega) \tanh(qt_{ox}) = 0,$$

(3)

where, $\epsilon_{\omega}(\omega)$ and $\epsilon_{\omega}(q, \omega)$ are the dynamic dielectric functions of the oxide and graphene, respectively. For bulk dielectrics, the frequency-dependent dielectric function can be written as

$$\epsilon_{\omega}(\omega) = \epsilon_{e} + \sum_{n} \frac{f_{n}^{0} \omega_{TO}^{n}}{(\omega_{TO}^{n})^{2} - \omega^{2}}.$$  

(4)

Here, $\epsilon_{e}$ is the high-frequency ($\omega \to \infty$) permittivity, $\omega_{TO}^{n}$ is the $n^{th}$ bulk transverse optical-phonon frequency, and $f_{n}$ is the corresponding oscillator strength of the dielectric oxide. The values of the strength for different dielectrics are extracted from experimental data as outlined in Ref. 20; the material constants are listed in Table I. In the long-wavelength limit ($q \to 0$), the dielectric function of graphene in the random-phase approximation is

$$\epsilon_{\omega}(q, \omega) = \frac{e^{2}}{\omega^{2}} \left[ 1 - \frac{\omega^{2}(q)}{\omega^{2}} \right].$$

(5)

Here, $\epsilon^{2} = (\epsilon_{\omega} + 1)/2$, $\omega_{\omega}(q) = \sqrt{q^{2} + \pi n}$ is the plasma frequency of single-layer graphene, $\alpha = e^{2}/2\pi e_{0}\kappa_{\omega}^{-1}h\nu_{F}$ is the effective fine structure constant of graphene, $e$ is the electron charge, $e_{0}$ is the permittivity of vacuum, $\hbar = h/2\pi$ is the reduced Planck’s constant, $\nu_{F} \sim 10^{6}$ m/s is the Fermi velocity characterizing the band structure of graphene, $n$ is the 2D carrier density, and $\kappa_{\omega}$ is the average dielectric constant of the system. For example, for graphene sandwiched between SiO$_2$($\kappa_{ai} = 3.9$) and air ($\kappa = 1$), $\kappa_{ai}^{-1}/(3.9 + 1)/2 = 2.45$. The numerical solution of Eq. (3) has three roots. Two of them represent interfacial phonon modes corresponding to two bulk TO modes of the dielectric and the third root represents the graphene plasmon mode. Figures 2(a) and 2(b) show the calculated dispersions of these three modes for a graphene layer on SiO$_2$ and ZrO$_2$. The SO phonon modes are found to be nearly dispersionless, except at the lowest wave vectors. The calculation of these dispersions show that the SO-phonon modes of the oxide-graphene-air system are not too different from the oxide-air interface. The effect of the graphene dielectric response on the SO modes is negligible since charges in graphene merely screen the electric field lines originating from the oxide-graphene interface. From the results in Fig. 2, we observe that $\omega_{\text{plasmon}} \ll \omega_{SO,1}, \omega_{SO,2}$. Hence, for the rest of the work we use the calculated dispersionless part of the SO phonon modes, the energies of these two modes for some of the commonly used dielectric gates are given in Table I.

### B. Interaction Hamiltonian and scattering rates

With the calculated SO-phonon frequencies above, the Hamiltonian of the electron-SO phonon system is given by

$$\mathcal{H} = \sum_{k} E_{k} \epsilon_{k} c_{k}^{\dagger} c_{k} + \sum_{q, \nu} \hbar \omega_{SO}^{\nu, \nu} a_{q}^{\dagger} a_{q} + H_{int},$$

(6)

where $E(k) = \pm \hbar \nu_{F} |k|$ is the kinetic energy of massless Dirac fermions close to the $(K, K')$ points of the graphene Brill-
FIG. 2. (Color online) Energy dispersion $\omega(q)$ of SO modes for graphene near the $\Gamma$ point of graphene on SiO$_2$ and ZrO$_2$. The two SO phonon modes labeled $\omega_{SO,1}, \omega_{SO,2}$ are nearly dispersionless (except near $q = 0$) and their magnitudes are close to the values in the absence of graphene. The graphene plasmon mode is energetically lower than surface modes.

The real-space representation of the 2D electron wave function of graphene close to the Dirac points. The electron-phonon coupling parameter $\kappa_{\alpha}$ is given by the coupled electron-phonon system can be written as

$$H_{ph} = eF \sum_q \left[ e^{-iq} e^{i\mathbf{q} \cdot \mathbf{r}} + e^{iq} e^{-i\mathbf{q} \cdot \mathbf{r}} \right],$$

where the electron-phonon coupling parameter $F$ is given by

$$F = \frac{\hbar \omega_{SO}}{2 \varepsilon_0} \left( \frac{\kappa_{\alpha}^0}{\kappa_{\alpha} + 1} \right),$$

where $\omega_{SO}$ is the high (low) frequency dielectric constant of the dielectric and $A$ is the area of graphene. We treat this interaction term perturbatively to calculate the electron-SO phonon-scattering rates. The wave function for the coupled electron-phonon system can be written as $|\Psi\rangle = |\chi\rangle|0\rangle$, where $|0\rangle$ is the phonon vacuum state and $|\chi\rangle$ is the electron wave function of graphene close to the Dirac points. The real-space representation of the 2D electron wave function of graphene near the $(K, K')$ points is given by the spinor form

$$\chi_e(\mathbf{k}, r) = (r)|\chi\rangle = e^{i\mathbf{k} \cdot \mathbf{r}} \begin{pmatrix} e^{-i\phi} & 1 \end{pmatrix},$$

where $\phi = \tan^{-1}(k_y/k_x)$, and $\mathbf{k}, r$ are the wave vector and spatial coordinate in the graphene plane. Since carriers are confined to the graphene plane, the $z$ extent of the electron wave function is assumed to be of the form $|z, \chi\rangle|^2 = \delta(z - d)$, $d$ is the equilibrium distance of the graphene sheet from the oxide surface. In one-phonon scattering process, the scattering matrix element is

$$\tau_{\mathbf{q}, \mathbf{q}'}^{\mathbf{q}, \mathbf{q}}(k, T) = \frac{1}{\hbar} \frac{\bar{F}(x, u)}{2 \pi \hbar^2 v_F} \times I^z(x, u),$$

where $\bar{F}(x, u)$ is a dimensionless integral that can be evaluated numerically, and $\pm$ stands for phonon emission ($n_{\mathbf{q}, \mathbf{q}'} = 1 + n_{\mathbf{q}, \mathbf{q}'}$) and absorption ($n_{\mathbf{q}, \mathbf{q}'} = n_{\mathbf{q}, \mathbf{q}'}$), respectively. The total scattering rate is obtained by summing the emission + absorption processes over all SO phonon modes,

$$\frac{1}{\tau_{ph}(k, T)} = \sum_{\mathbf{q}} \frac{\Theta(E - \hbar \omega_{\mathbf{q}})}{\tau_{\mathbf{q}, \mathbf{q}}^{\mathbf{q}, \mathbf{q}}(k, T)} + \frac{1}{\tau_{\mathbf{q}, \mathbf{q}}^{\mathbf{q}, \mathbf{q}}(k, T)},$$

where $\Theta(\cdots)$ is the Heaviside unit-step function. Figure 3(a)
shows the SO phonon-scattering rates at room temperature calculated using the above formalism for graphene located on five different polar dielectrics. For this plot, a 2D carrier concentration of \( n = 10^{12}/\text{cm}^2 \) and an equilibrium graphene-oxide distance of \( d = 0.4 \) nm is used.\(^{17}\) Figure 3(b) shows the dependence of the SO phonon scattering rate on the graphene-dielectric distance for three different values of \( d \). As expected from the decay of the SO phonon evanescent mode from the dielectric surface, the scattering rate reduces with increasing \( d \). The kinks in the scattering rates in Fig. 3(a) indicate the onsets of SO phonon-emission processes, as indicated by arrows. \( \text{ZrO}_2 \) with the highest low-frequency dielectric constant (\( \varepsilon_0 \approx 24 \)) shows the strongest electron-SO phonon scattering among the five and \( \text{SiO}_2 \) shows the lowest. If SO phonons were the sole scattering mechanism responsible for limiting the low-field mobility of graphene, this analysis would indicate that using a low-\( \kappa \) dielectric would be the most beneficial. However, the presence of charged impurities and Coulombic scattering due to them changes this simplistic picture.

C. Ionized impurity scattering

The scattering rate due to charged impurities present in the graphene-dielectric interface is given by

\[
\frac{1}{\tau_{\text{imp}}(k)} = \frac{n_{\text{imp}}}{\pi \hbar} \left( \frac{e^2}{2 \varepsilon_0 \kappa_{\text{avg}}} \right) \frac{1}{\varepsilon(k)} \int F(a) \, \frac{\alpha^2 F(a) \tau_{\text{imp}+} \nu_{\text{F}}}{k},
\]

where \( n_{\text{imp}} \) is the sheet density of impurities at the interface, \( a = \alpha(k_F/k) \) is a dimensionless argument with \( \alpha \) the effective fine-structure constant defined earlier following Eq. (5), \( k_F \) is the Fermi wave vector, and the dimensionless function \( F(a) \) is defined in Ref. 24. \( \kappa_{\text{avg}} \) is given by the average relative dielectric constant of the two regions surrounding graphene: \( \kappa_{\text{avg}} = (\kappa_{\text{top}} + \kappa_{\text{bottom}})/2 \). In typical cases, it is \( \text{SiO}_2 \) and air, implying \( \kappa_{\text{avg}} = (1 + \kappa_{\text{SiO}_2})/2 \approx 2.45 \).

III. RESULTS AND DISCUSSIONS

As it is clear from Eq. (14), the impurity scattering rate can be strongly suppressed by using high-\( \kappa \) dielectric materials next to graphene. This was pointed out earlier in Ref. 14 for the general case of semiconductor nanoscale membranes. However, using a high-\( \kappa \) material also enhances surface-optical phonon-scattering rates, as based on the earlier analysis in this work. With increasing dielectric constant of the graphene environment, impurity scattering is damped, but SO phonon scattering increases, indicating an optimal choice of the dielectric exists for obtaining the highest mobilities for graphene located on substrates. Figure 4(a) illustrates this fact for graphene on five different dielectrics with increasing low-frequency dielectric constants at room temperature for an impurity density of \( n_{\text{imp}} = 5 \times 10^{11}/\text{cm}^2 \) and a carrier concentration \( n = 10^{12}/\text{cm}^2 \). The mobility \( \mu = \sigma / n e \) is calculated from the conductivity using the relation \( \sigma(T) = (e^2/\hbar) 2 \nu_{\text{F}} k_F \tau \). The solid curve is the predicted enhancement of mobility due to the damping of Coulombic impurity scattering and the hollow circles indicate the expected mobility for the particular dielectrics if SO phonon scattering was absent (these are calculated with \( \tau = \tau_{\text{imp}} \)). The filled circles show the degradation of the mobility due to SO phonon scattering; for these values of mobility, \( \tau_{\text{imp}} = (\tau_{\text{ph}}^{-1} + \tau_{\text{imp}}^{-1})^{-1} \) is used. It is evident that SO phonon scattering nearly washes out the improvement of mobility that could have resulted from the reduction in impurity scattering, and RT mobilities are limited to \( \mu_{\text{RT}} \approx 10^4 \text{ cm}^2/\text{V s} \), as indicated by the shaded band. The effect of SO phonon scattering might seem minimal for \( \text{SiO}_2 \), but it is important to note that the SO phonon scattering is independent of the impurity concentration; therefore a purer graphene/oxide interface will still result in substantial SO phonon scattering and mobilities in this regime. In Fig. 4(b) we plot the carrier conductivity in graphene for two different materials, \( \text{SiO}_2 \) and \( \text{ZrO}_2 \). The solid lines correspond to conductivity due to impurity scattering alone while the dashed lines incorporate the effect of both impurity and surface-optical phonons. The conductivity is linear with carrier concentration in agreement with experiments.\(^9\) Due to the importance of SO phonon scattering, mobility is also expected to be temperature dependent with lowering of temperature, the reduction in SO phonon scattering will result in an increase in mobility from the filled circles in Fig. 4(a) to the hollow circles. Figure 5(a) shows the temperature-dependent carrier mobility for graphene on different dielectrics. Indeed, at low temperatures, electron mobility can be improved by a factor of 4 (gray curve in Fig. 5) by putting graphene on high-\( \kappa \) dielectrics (here \( \text{ZrO}_2 \)) but at room temperatures, mobility values are close to \( 10^4 \text{ cm}^2/\text{V s} \) on all dielectrics due to strong surface-phonon scattering. The carrier concentration \( n \) dependence of carrier mobility can be understood by simple mathematical arguments. As square of scattering matrix element \( |M_s^2(q)|^2 \sim 1/q \) [see Eq. (10)] and graphene density of states \( g(q) \sim q^3 \) without screening, scattering rates \( \tau^{-1} \sim |M_s^2(q)|^2 \times g(q) = \text{constant} \) [saturation behavior of scattering rates as shown in Fig. 3(a)]. Hence, conductivity \( \sigma(n) \approx k_F \) and elec-
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FIG. 5. (Color online) (Left) (a) Electron mobility in graphene as a function of temperature on different gate dielectrics at carrier density n=10^{12}/cm^2. Note that high-κ dielectrics reduce Coulombic impurity scattering and increases carrier mobility by a factor of 4 at low temperatures but strong SO phonon scattering by them (shaded part) reduces the RT mobilities to ~10^5 cm^2/V s. (Right) (b) Electron and hole conductivity as a function of carrier concentration for graphene on different dielectrics at T=300 K. For all calculations above impurity density is assumed to be 5×10^{11}/cm^2.

IV. CONCLUSIONS

In conclusion, we have investigated the effect of various dielectrics on the electron mobility in single-layer graphene by considering the effects of impurity and SO phonon scattering. By calculating the remote polar optical-phonon scattering arising from the polar substrates, and combining it with their effect on Coulombic impurity scattering, a comprehensive picture of the effect of dielectrics on charge transport in graphene emerges. We have shown that at low temperatures, high-κ dielectric reduces the charged impurity scattering resulting 4–5 times enhancement of electron mobility in graphene in addition to improved capacitive charge control of the graphene-based field effect transistors (g-FETs). At room temperatures this mobility enhancement is washed out (mobility is reduced compared to graphene on low-κ dielectrics such as SiO_2) by strong surface-optical-phonon scattering leaving little or no room for mobility improvement. Among commonly available dielectrics, intermediate-κ dielectrics (such as AlN and SiC) are optimum choice as gate insulators where nominal mobility enhancement is possible (μ∼15 000 cm^2/V s) compare to ubiquitously used low-κ gate dielectric SiO_2.

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APPENDIX A: RECENT EXPERIMENTAL RESULTS

In this section we will discuss some of the recent transport experiments for graphene based devices in different dielectric media. To our best knowledge, we are aware of three
experimental reports so far for graphene in high-κ environments. Among them, two experiments\(^{18,37}\) were done using high-κ organics solvents and reported contradictory results. As our theory is restricted to crystalline gate oxides, a quantitative comparison of experiments with liquid gates to our theory is beyond the scope of the work presented here. Nevertheless, a qualitative explanation can be made for the sake of completeness of charge transport in high-κ dielectrics. Ponomarenko et al.\(^{18}\) has reported graphene mobility to be insensitive to dielectric environments while Chen et al.\(^{37}\) reported order of magnitude enhancement in carrier mobility. The insensitivity of carrier mobility on environmental dielectrics as reported in Ref. 17 can well originate from two reasons: (i) the gate-leakage current due to insufficient electrical isolation can result in erroneous measurement. (ii) Moreover, formation of Stern layer\(^{38}\) at graphene-liquid interface will increase charged impurity scattering and compensate the effect of dielectric screening partially, if not by full extent. On the other hand, Chen et al. performed experiments with proper electrical isolation (covered electrodes with Ti) and used SiO\(_2\) back gate instead of liquid top gate. Use of high-κ aprotic (no hydrogen bonds) organic solvent not only enhanced Coulomb screening but also compensated charged impurity by inducing counter ions at graphene-liquid interface.\(^{39}\) Long-range surface-phonon vibrations are absent in liquids and surface phonon of crystalline SiO\(_2\) backgate are not activated low-field transport at room temperatures (see Fig. 5). As a result, Chen et al. has observed a significant increase in carrier mobility using high-κ aprotic liquids.

For practical g-FET devices, use of liquid environments is not a feasible idea and a solid (crystalline) high-κ environment is desirable for large-scale production. The third and most recent experiment\(^{40}\) has reported transport results of graphene-FET using HfO\(_2\) as top gate. Though high-κ HfO\(_2\) top gate enhances electrostatic doping in graphene, strong surface phonon field arising from topgate together with impurity scattering limits the carrier mobility around 10000 cm\(^2\)/V s. This is a direct experimental evidence of the theoretical work presented in this paper. It should be noted that experimentally extracted value of HfO\(_2\) SO-phonon limited mobility (~20000 cm\(^2\)/V s) is higher than our calculated value (~15000 cm\(^2\)/V s). This discrepancy stems out from the fact that in the experiment by Zou et al. thin (~10 nm) HfO\(_2\) top gate was amorphous in nature with a single SO-phonon mode at 54 meV, whereas in our theory, thick HfO\(_2\) crystalline gate has a low-lying SO-mode (~20 meV, see Table I) in addition to the high-energy mode. The exclusion of low-energy SO mode from our scattering calculations will result in SO-phonon limited mobility reasonably close to the experimentally obtained value.

**APPENDIX B: DETAILS OF ELECTRON-SO PHONON-SCATTERING STRENGTH**

Here we will outline the detail calculation of electron-SO phonon interaction potential. The potentials in Eq. (2) are undetermined by a constant \(b_{q,a}^{\pm}\) and \(b_{q,a}^{-}\) is related to \(b_{q,a}^{\pm}\) by the relation \(b_{q,a}^{-} = 2b_{q,a}^{\pm}\sinh(qt_{ox})\). This constant can be determined by semiclassical argument originally proposed by Stern and Ferrel\(^{41}\) and later employed by Fischetti for 2D nanoscale MOSFETs.\(^{20}\) We first consider the time-averaged total electrostatic energy, \(\langle W_{q}^{(i)} \rangle\) (bra-kets \(\cdots\)) stands for time average associated with the field \(\phi_{q}^{(i)}(r,t)\) caused by the excitation of mode \(i\) oscillating at the frequency \(\omega_{q}^{(i)}\) (root of the secular Eq. (3)). As fields are harmonic oscillations in time, the total energy is just the two of the time-averaged potential energy, \(\langle W_{q}^{(o)} \rangle = 2\langle \langle q \rangle \rangle\). By evaluating electric field \(E'(r,t) = -\nabla \phi_{q}^{(i)}(r,t)\), the electrostatic energy can be expressed as

\[
\langle W_{q}^{(i)} \rangle = 2\langle \langle q \rangle \rangle = 2\left( \int_{-\infty}^{\infty} dz \int_{0}^{\infty} rdr\epsilon(\omega_{q}^{(i)},r)|E'(r,t)|^{2} \right)
\]

\[
= d_{q,a}^{-}\Delta q[\epsilon_{q}(\omega)\coth(qt_{ox}) + 1].
\]  

(B1)

The unknown constant \(d_{q,a}^{-}\) now can be determined by equating the total electrostatic energy to the energy of quantized harmonic oscillator in their ground state, i.e., \(\langle W_{q}^{(o)} \rangle = \hbar\omega_{q}^{(i)}/2\). Furthermore, polarization field associated with ith SO phonon is given by the difference of square amplitudes of high frequency \(\epsilon_{q}(\omega) = \epsilon_{q}^{+}\) and zero-frequency \(\epsilon_{q}(\omega) = \epsilon_{q}^{-}\) response of bulk insulator phonons as outlined by Fischetti et al.\(^{20,42}\) Implementing the procedure outlined above, the scattering potential inside graphene membrane for ith SO phonon can be written as (in the limit \(qt_{ox} \to \infty\)),

\[
\mathcal{H}_{in} = \left[ \frac{\epsilon_{q}^{+}\omega_{SO}^{2}}{2Aq} \left( \frac{1}{\epsilon_{q}^{+} + 1} - \frac{1}{\epsilon_{q}^{-} + 1} \right) \right]^{1/2} \exp(-aq),
\]

\[
\times (e^{iqr} + e^{-iqr})
\]  

(B2)

Comparing with Eq. (7), we get the expression of \(\mathcal{F}_{q}\) as given in Eq. (8).

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27. The integral \( I^2(x,u) = \int_0^\pi d\theta e^{-2u\pi^2\sin^2(\theta/2)} |p^2(x,\theta)|^2 \), where \( p^2(x,\theta) = \sqrt{x(x \mp 1)(1-\cos \theta)} + 1 \) and \( \lambda_x = e^2k_F^2/(\pi \epsilon_0 \kappa_{ox} \hbar \omega_{SO_x}) \).
42. The integral \( I^2(x,u) = \int_0^\pi d\theta e^{-2u\pi^2\sin^2(\theta/2)} |p^2(x,\theta)|^2 \), where \( p^2(x,\theta) = \sqrt{x(x \mp 1)(1-\cos \theta)} + 1 \) and \( \lambda_x = e^2k_F^2/(\pi \epsilon_0 \kappa_{ox} \hbar \omega_{SO_x}) \).
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46. F. Chen, J. Xia, and N. Tao, Nano Lett. 9, 1621 (2009).
49. If there exists more than one TO phonon modes in the insulator, it is nontrivial to separate out individual contributions of different TO-phonon modes to a single SO-phonon mode. Section C of Ref. 19 illustrates a systematic procedure to separate out contributions of different TO modes on a single TO mode. In our case, we assumed oxides have two bulk TO modes and they are weakly coupled together via Eq. (3). Nevertheless, we can ignore this weak coupling between two TO phonons (because of their large difference in energy) and assume SO1 (SO2) mode is arising solely due to TO1 (TO2) phonon without incorporating significant error in the calculations.